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Ethanol and Hydrogen Gas-Sensing Properties of CuO–CuFe₂O₄ Nanostructured Thin Films

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Abstract—Nanocrystalline CuO–CuFe₂O₄ composite thin films were developed from CuFeO₂ ceramic target using a radio-frequency sputtering method followed by a thermal oxidation process. This fabrication process helps to develop porous sensing layers which are highly desirable for solid-state resistive gas sensors. Their sensing properties toward ethanol and hydrogen gas in dry air were examined at the operating temperatures ranging from 250 °C to 500 °C. The electrical transients during adsorption and desorption of the test gases were fitted with the Langmuir single site gas adsorption model. A composite thin film with a total thickness of 25 nm showed highest response (79%) toward hydrogen (500 ppm) at the operating temperature of 400 °C. The shortest response time (τ_{res}) was found to be ~ 60 and ~ 90 s for hydrogen and ethanol, respectively. The dependence of the response of the sensor on gas concentration (10–500 ppm) was also studied.

Index Terms—Ethanol, gas sensor, hydrogen, nanocrystalline CuO–CuFe₂O₄, thin film.

I. INTRODUCTION

METAL oxide semiconductors (MOS), such as pure CuO phase or CuO coupled with other MOS in a composite material, have been used as sensor materials for many years for the detection of reducing gases such as hydrogen [1], [2], ethanol [3]–[7], CO [8], [9], and H₂S [10]–[12]. Recently, various nano structures of CuO like one-dimensional (1D) nano wire and thin films have caught attention due to high surface to volume ratio which is expected to enhance the performance of the devices based on semiconductor nano structures [13]. Porous CuO nano wires [14], CuO/ZnO hetero contact sensors [15] and Zn doped CuO nano wires [16] were reported for improving H₂ detection. In addition with all

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the gases listed above, CuO can also be interesting for CO₂ detection [17]. On the other hand, copper based spinel oxides such as copper ferrite (CuFe₂O₄) having n-type semiconductor properties was also reported to show response toward H₂ [18], LPG [19] and ethanol [20]. In our previous work, maximum response ($\Delta R/R$) of 86% was obtained by CuFe₂O₄ nano powder toward 500 ppm of ethanol [21], and this pure copper ferrite also showed a good response of 10% toward CO₂ [22].

Semiconductor nano composites with p–n junction were reported as a subject of interest for gas sensing regarding operating temperature (O.T.) and response. In particular, many authors have studied the combination of p-type CuO with various n-type oxides for CO₂ detection [23]–[26]. In the recent past, CuO/CuFe₂O₄ composite thin films [27] and powders [22] having spinel phase were also reported as CO₂ gas sensing material.

In this work, nanocrystalline CuO–CuFe₂O₄ semiconductor thin films were developed from CuFeO₂ ceramic target using a radio-frequency (RF) sputtering method followed by a thermal oxidation process. This fabrication process may help to develop porous sensing layers which are highly desirable for solid state resistive gas sensors. These films were used as the sensitive material for reducing gases like hydrogen and ethanol. The effect of the operating temperature on the response, response time and recovery time of the active layer were studied to evaluate the merit of performance of the material. The effect of gas flow rate on the response time and recovery time of the active layer were also studied. To demonstrate its potential sensing application, the variation of response with different gas concentration has been shown. Here, the minimum operating temperature was chosen as 250 °C to avoid the effect of moisture on sensor samples during practical gas sensing application. We also tried to generate the values of activation energy for the gas (H₂) adsorption and intrinsic reaction on CuO thin film surface using Langmuir gas adsorption model, which may be useful in future to compare with other sensing material and gases for analysing the gas sensing properties.

II. PREPARATION OF THE GAS SENSITIVE LAYERS

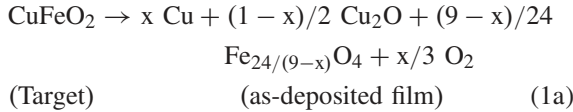
Cu–Cu_xFe_{3–x}O₄ thin films were first deposited on fused silica substrate at room temperature with Alcatel A450 RF sputtering unit using a pure delafossite (CuFeO₂) ceramic target. The details of the deposition procedure were described

TABLE I
DEPOSITION PARAMETERS FOR THE SPUTTERING

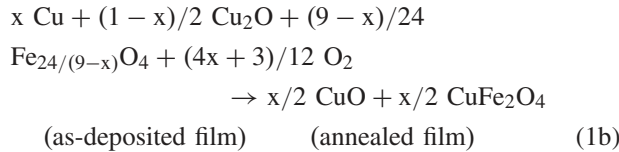
Target	CuFeO ₂
Magnetron	No
RF power (W)	200
Argon pressures (Pa)	0.5
Target to substrate distance (cm)	5
Substrate	Fused silica
Deposition rates (nm/min)	6.8

by Barnabé *et al.* [28]. Process parameters for the room temperature deposited samples are given in Table I. Two films having thicknesses 25 nm and 300 nm were deposited by varying the deposition time. Thickness of the deposited films was measured using a Dektak 3030ST profilometer and cross-sectional scanning electron microscopy (SEM) using JEOL JSM 6700F field emission SEM. Our previous studies (i.e. grazing incidence X-ray diffraction (GI-XRD), Raman spectroscopy and electron probe micro analysis (EPMA)) on the same samples have already revealed that the as-deposited films consisted of copper nano particles which were embedded in an oxide matrix which was made of cuprous oxide and mixed valence defect ferrite (Cu₂O, Cu_xFe_{3-x}O₄) [28], [29] (Equation 1a). In order to obtain the stable CuO/CuFe₂O₄ nano composite, the as-deposited films were ex-situ annealed at 550 °C in air for 12 h (Equation 1b). The tenorite phase CuO then originated from the oxidation of the metallic copper in association with that of Cu₂O. One can note that the reaction scheme could be more complex if we consider the formation of CuFeO₂ intermediate phase [29]. The annealing treatment of the as-deposited samples starting from delafossite target can be represented by the following simplified reaction scheme:

- 1) reduction during deposition step



- 2) oxidation during post deposition annealing



The SEM image in figure 1 shows that, as a result of annealing, the parent films were self-organized in a two layered stack with top to bottom layer thickness ratio of 1:2. These films were characterized by GI-XRD technique and Glow-discharge optical emission spectroscopy (GD-OES) profile [27] and X-ray photo electron spectroscopy (XPS) [29] which confirmed that the top layer was tenorite CuO and that of the bottom layer was spinel CuFe₂O₄.

Interestingly, a 30% increase in the total thickness of the as-deposited thin film was observed after annealing which was possibly due to the porosity developed during post-deposition annealing [29]. This porosity in the two layered stack might be caused by the metallic copper diffusion during

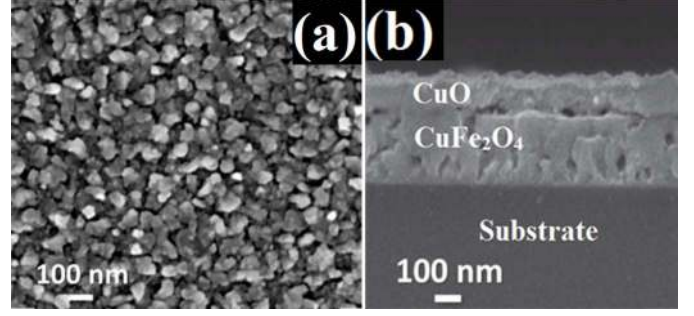


Fig. 1. FE-SEM micrographs (a) plain view and (b) cross section view of the sample annealed at 550 °C for 12 hours in air.

the oxidation process of the as-deposited samples. For thin film semiconductor metal oxide based gas sensors, the porosity of the sensing layer is an important parameter [30] as the gas diffusion through the porosity can cause changes in electrical properties of the films, making the gas detection easier.

III. GAS SENSING MEASUREMENTS

Gas sensing experiments were carried out in a closed chamber with controlled operating temperature from 250 °C to 500 °C using a PID controller. The ambient gas environment was controlled by a continuous flow of the calibrated test gases or air using mass flow controller. For the hydrogen sensing, two gas cylinders were used- one with just zero air (moisture < 0.01%) and another with same zero air containing 500 ppm of hydrogen. The sensor samples were stabilized at each operating temperatures for at least 12 hours in zero air, prior to the gas sensing experiment. Resistance-transients of the sensing layer were measured in two probes mode using Keithley 2635B source meter. Similarly, for the ethanol sensing experiments, two gas cylinders were used, one with zero air and another with the same zero air containing 500 ppm of ethanol. The response (R_s) of the sensor samples is defined as the relative difference of the film resistance between air and test gas atmosphere ($(R_{\text{gas}} - R_{\text{air}}) / R_{\text{air}} \times 100\%$), where R_{gas} and R_{air} are saturated resistance of the sensor in test gas atmosphere and in air respectively. The concentration of the test gases (C_{gas} in chamber) in the gas chamber was varied by diluting with zero air, and it can be calculated using the following relation:

$$C_{\text{gas in chamber}} = [C_{\text{test gas}} \times (dV_{\text{test}}/dt)] / [(dV_{\text{test}}/dt) + (dV_{\text{zero air}}/dt)] \quad (2)$$

Where $C_{\text{test gas}}$ is the concentration of the test gas in gas cylinder and dV_{test}/dt is the volumetric flow rate of test gas, similarly $dV_{\text{zero air}}/dt$ is the volumetric flow rate of zero air.

IV. RESULTS AND DISCUSSION

Figure 2 shows the resistance-transients during the insertion of hydrogen (500 ppm) and recovery in air of the 25 nm thin film sensor at the operating temperature of 400 °C with 100 cc/min gas-flow rate. The sensing material showed good repeatability as the initial baseline was regained upon exposure to dry air. The increase in the electrical resistance of the

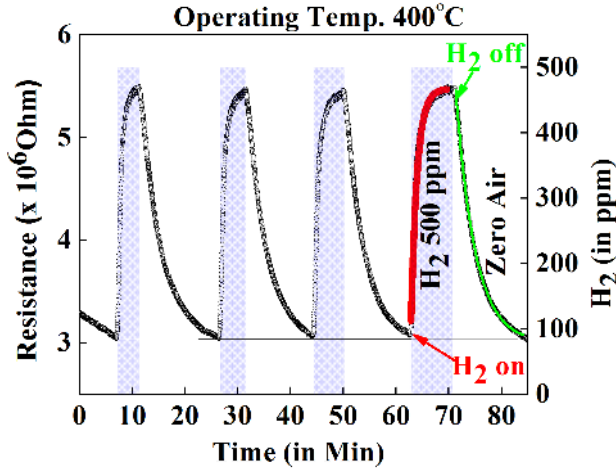


Fig. 2. Resistance-transients (response and recovery) of the 25 nm thin film sensor at the operating temperature of 400 °C with 100 cc/min flow rate, fittings are shown in coloured lines.

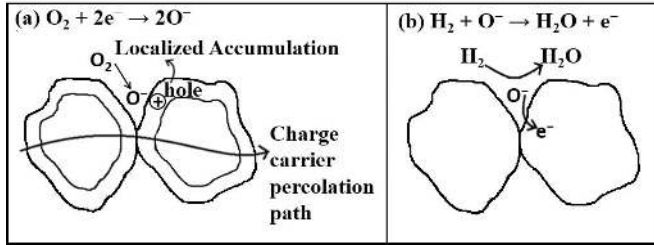
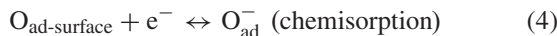
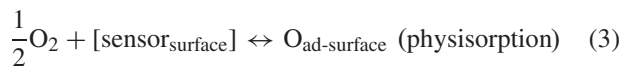


Fig. 3. Schematic of the proposed sensing mechanism- (a) during stabilization of the sensor material (oxygen adsorption); (b) during sensing of the test gas (e.g. hydrogen).

sensors upon exposure to a reducing gas such as H_2 indicates that the obtained films have p-type semiconducting behaviour. It could be possible that only CuO is involved in sensing as it is the top layer.

The following reaction mechanism for the sensing of reducing gas by a p-type semiconductor can be summarized from several research reports [3]. In a first step, at the operating temperature, oxygen is physisorbed on the sensor surface followed by electron transfer from the p-type semiconducting oxide CuO to the adsorbed oxygen, thus forming chemical bond between the adsorbed oxygen and the semiconducting oxide. Thus, the electrical resistance of the p-type semiconductors reduces during stabilization of the sensor material [see figure (3.a)].

These reactions are described in equations (3) and (4) respectively



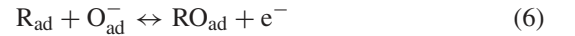
When the sensor is exposed to reducing gas ambient, the reducing gas is physically adsorbed on the active layer surface and reacts with the adsorbed oxygen according to the reaction (5) & (6) and the product (RO) goes out [eq. 7] [see figure (3.b)]. Thus, the resistance of the p-type sensor

TABLE II

VARIATION IN RESPONSE TIME AND RECOVERY TIME WITH GAS-FLOW RATE AT A FIXED OPERATING TEMPERATURE (500 °C); 25 nm COMPOSITE THIN FILM

Gas flow rate (in cc/min)	τ_{res} (in s)	τ_{rec} (in s)
20	137	221
50	82	190
100	63	131

increases.



Out of these reactions, the physisorption of oxygen as well as that of the reducing gas [Eq. (3) and (5)] are fast. On the other hand the reaction between the adsorbed gas and oxygen [Eq. (6)] is a slow process and therefore, the last one is the rate determining step for the response kinetics. This is easily corroborated from the reported data on surface reaction of adsorbed oxygen [31] and hydrogen [32]. According to Ahn *et al.* [31], the ratio of surface reaction rate constant to adsorption rate constant at adsorption equilibrium for oxidation of sulphur dioxide is 0.5, and Arrua *et al.* [32] reported the same ratio for hydrogenation using Pd/Al_2O_3 catalyst in the range of 0.26-0.29. Assuming Langmuir single site gas adsorption model for the thin film sensors [33], the response and the recovery transients were fitted well with the following two equations (eq. 8, 9) respectively (shown in coloured lines in fig. 2). The values of coefficient of determination (R^2) in this fitting for all response or recovery curves were in between 0.985-0.999.

$$R(t)_{\text{response}} = R_{\text{air}} + R_1[1 - \exp(-t/\tau_{\text{res}})] \quad (8)$$

$$R(t)_{\text{recovery}} = R_{\text{air}} + R_1[\exp(-t/\tau_{\text{rec}})] \quad (9)$$

Where τ_{res} and τ_{rec} are the ‘response time’ and ‘recovery time’ respectively. And R_1 is a proportionality constant of the exponential term whose value is equal to the difference of the film resistance between air and test gas atmosphere ($R_{\text{gas}} - R_{\text{air}}$).

The variation of response and recovery time with gas flow rate was observed and tabulated in Table II. Decrease in response and recovery time with gas flow rate indicates a mass transfer controlled reaction kinetics on this thin film surface. Therefore, the flow rate was kept fixed at 100 cc/min for the rest of the experiments performed.

Hydrogen sensing by a 25 nm thin film sensor was carried out at different operating temperatures and the variation of response time and recovery time are given in the table III. Response time seemed to be saturated above the operating temperature of 350 °C and the saturated value was found to be around 60 seconds. At the high operating temperatures, the reaction rate of eq. (6) became faster and the reaction might be limited by the test conditions, i.e., gas flow in the gas chamber. Recovery time decreased monotonically with the operating temperature until 500 °C.

TABLE III

VARIATION IN RESPONSE TIME AND RECOVERY TIME OF 25 nm THIN FILM SENSOR WITH THE OPERATING TEMPERATURE (TEST GAS: 500 ppm OF H₂ WITH 100 cc/min FLOW RATE)

Operating Temperature (in °C)	τ_{res} (in s) (error)	τ_{rec} (in s) (error)
250	276 (± 11)	667 (± 27)
300	116 (± 5)	416 (± 17)
350	58 (± 3)	249 (± 10)
400	58 (± 3)	221 (± 9)
450	56 (± 3)	186 (± 8)
500	63 (± 3)	131 (± 6)

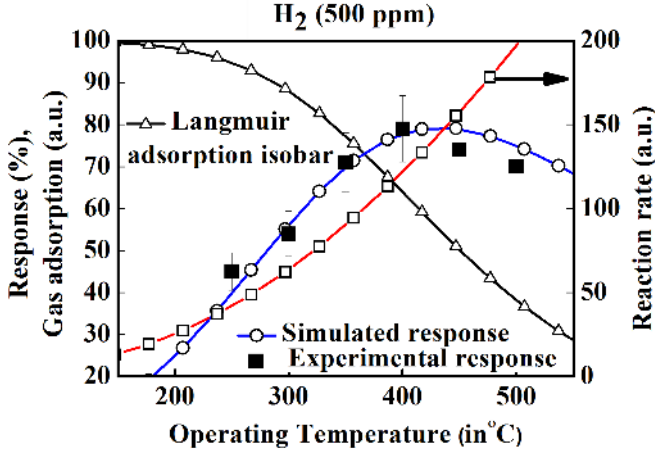


Fig. 4. Experimental and simulated response vs. operating temperature of 25 nm composite thin film (test gas: 500 ppm of H₂ with 100 cc/min flow rate).

The bell shaped response curve with the operating temperature as shown in the figure 4 is a result of the competitive behaviour of eqs. (5) and (6). Similar bell shaped response curve had been reported by Ahlers *et al.* [34] and Biswas and Pramanik [35]. According to them, response varies with operating temperature on the basis of two energy systems. E_{ads} is dependent on the strength of the test gas binding onto the sensing material surface. On the other hand, E_a is defined as the energy barrier required to be overcome by the adsorbed gas molecules for diffusion along the surface, resulting in catalysis induced surface combustion process. Initially, under clean air conditions, active sites on the surface of a sensor material had been covered by adsorbed oxygen. Then, relative occupancy of the test gas on the pre-adsorbed oxygen depends on partial pressure and operating temperature of the test gas. In the figure 4, simulated curves of Langmuir relative surface coverage (L), reaction rate (K) and the modeled response (R_m) are shown. Here,

$$L = \frac{P_{gas}}{P_{gas} + P_o} \quad (10)$$

where P_{gas} is partial pressure of test gas (H₂) at sensing layer and $P_o = \frac{k_B T}{v_o} \exp\left(\frac{-E_{ads}}{k_B T}\right)$, where v_o is the quantum volume of the test gas species, given by $v_o = \left(\frac{2\pi h^2}{M_{gas} M_o k_B T}\right)^{1.5}$, where M_{gas} is the relative atomic mass of the test gas (i.e. 2 for H₂); M_o is the atomic mass unit (1.67×10^{-27} kg);

TABLE IV

CHANGE IN RESPONSE TIME AND RECOVERY TIME OF 25 nm THIN FILM SENSING MATERIAL WITH THE OPERATING TEMPERATURE (TEST GAS: 500 ppm OF ETHANOL WITH 100 cc/min FLOW RATE)

Operating Temperature (in °C)	τ_{res} (in s) (error)	τ_{rec} (in s) (error)
250	432 (± 17)	740 (± 30)
300	223 (± 9)	440 (± 18)
350	150 (± 6)	370 (± 15)
400	121 (± 5)	390 (± 16)
450	90 (± 4)	450 (± 18)
500	90 (± 4)	480 (± 19)

\hbar is the reduced plank constant and k_B , T are Boltzmann constant and absolute temperature respectively. The reaction rate of adsorbed test gas with chemisorbed oxygen ion is

$$K = A \exp\left(\frac{-E_a}{k_B T}\right) \quad (11)$$

where A is a proportionality constant. The modeled response was obtained from the combination of Langmuir relative surface coverage and the reaction rate [34], and it could be given by

$$R_m = \frac{P_{gas}}{P_{gas} + \frac{k_B T}{v_o} \exp\left(\frac{-E_{ads}}{k_B T}\right)} A \exp\left(\frac{-E_a}{k_B T}\right) \quad (12)$$

In the case of tin dioxide (SnO₂) thin film sensors, the values of E_{ads} varied from 130 to 145 kJ/mol (1.3-1.45 eV) and E_a varied from 53 to 57 kJ/mol (0.53-0.57 eV) for different ethane concentrations [34]. Here, the values E_{ads} and E_a were obtained (by the fitting of experimental values with eq. 12) as 43 kJ/mol (0.45 eV) and 21 kJ/mol (0.22 eV) respectively. This sensor sample showed maximum response of 79% at the operating temperature of 400 °C toward 500 ppm of H₂. A similar response of 70% was reported for H₂ but at a higher concentration (2500 ppm) with thicker copper oxide-copper ferrite sensor system [36]. Hoa *et al.* [2] reported 40% response toward 10,000 ppm of H₂ at an operating temperature of 250 °C for CuO thin film, whereas at the same operating temperature, this CuO/CuFe₂O₄ thin film exhibits 45% response only at 500 ppm of H₂.

Similarly, ethanol sensing of the 25 nm thin film sensor was carried out at different operating temperatures and the variation of response time and recovery time are given in the table IV. Response time seemed to be saturated above the operating temperature of 450 °C and the value of that was found to be around 90 seconds. It was observed that the recovery time decreased to the range of 350 to 400 °C and after that it had increased. This increase at 500 °C is not well understood at present. Figure 5 shows the variation of response with operating temperature. In case of ethanol, the maximum response of this thin film sensor might be observed above 500 °C. As per literature, the best operating temperature to get maximum response for ethanol was reported to be higher than that of hydrogen [37]. The operating temperature was confined below 500 °C due to the (a) stability of the phase and microstructure in sensing layers and (b) instrumental limitation. Hence we may not be able to capture a similar behaviour as found in H₂.

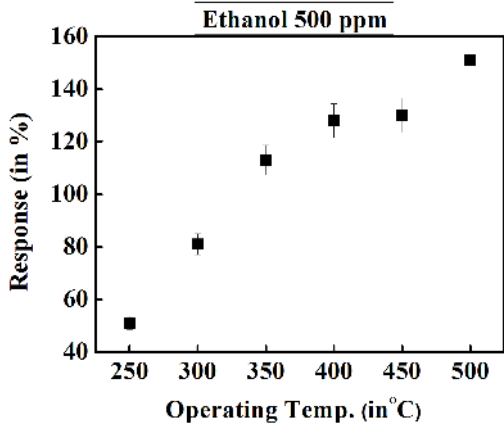


Fig. 5. Response vs. operating temperature of 25 nm thin film sensing material (test gas: 500 ppm of ethanol with 100 cc/min flow rate).

TABLE V

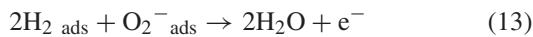
RESPONSE TIME, RECOVERY TIME AND RESPONSE VS. FILM-THICKNESS

Thickness of films (nm)	Test gas (500 ppm)	Operating Temperature (°C)	τ_{res} (s)	τ_{rec} (s)	R_s (%)
25	Ethanol	450	90	450	130
300	Ethanol	450	204	800	114
25	H ₂	400	58	221	79
300	H ₂	400	230	790	68

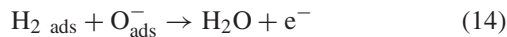
Here, due to lack of the bell shape in the response curve, it could not be fitted with the chosen model (eq.12).

The gas sensing experiment was carried out with 300 nm thick film and the results are tabulated in table V. Thicker CuO–CuFe₂O₄ thin film showed p-type response toward reducing gases, i.e., hydrogen and ethanol. So, the test gases were mostly interacting (adsorption/desorption) with the copper oxide layer located on the top of film.

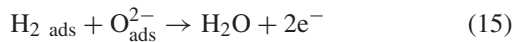
Depending on the operating temperature, oxygen molecules adsorbed on semiconductor surface are in various ionic states, i.e. O₂⁻, O⁻ or O₂²⁻ [38]. So, adsorbed hydrogen (H₂_{ads}) may react with adsorbed oxygen (O_{ads}^{ion}) as in the following equations.



or,

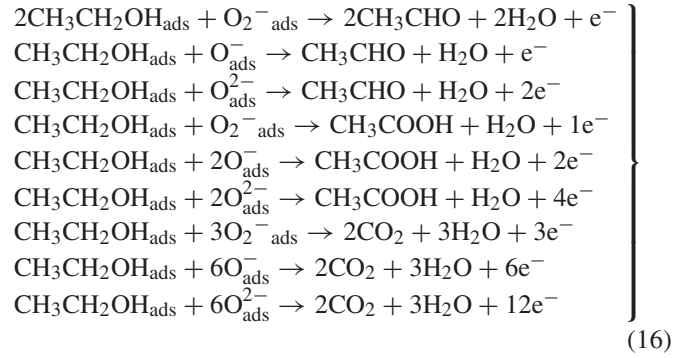


or,



Similarly, carbon dioxide and water are the final decomposition products of ethanol combustion in air. Acetaldehyde or acetic acid may also form as intermediate products during the oxidization of ethanol. Hence depending on the types of adsorbed oxygen and by-products of ethanol, various charge balance equations of ethanol decomposition are

possible and given below.



From equations (13), (14) and (15), for all metal oxide sensors a general rate equation of electron density can be written as

$$\frac{dn}{dt} = K_{gas}(T)[O_{ads}^{ion}]^a[R]^b \quad (17)$$

where, n is the electron density or electron concentration in the charge accumulation layer under the test gas (e.g. H₂) atmosphere, b is a charge parameter which might have value in the range of 0.5 to 2 for hydrogen and 0.08 to 2 for ethanol respectively. Similarly, a is a charge parameter which might have value in the range of 0.5 to 1 for oxygen ions. K_{gas}(T) is the reaction rate constant or reaction rate coefficient described as

$$K_{gas}(T) = A \exp(-E_a/k_B T) \quad (18)$$

where E_a is the activation energy of reaction, k_B is the Boltzmann constant, T is absolute temperature and A is proportionality constant. Integrating Eq. (17) leads to the solution as

$$n = K_{gas}(T)[O_{ads}^{ion}]^a[R]^b t + n_0 \quad (19)$$

where n₀ is the saturated electron concentration of sensor at an operating temperature in the air atmosphere. In the saturated ethanol, i.e., at equilibrium under ethanol and air atmosphere, carrier concentration n and n₀ could be considered as a constant with time.

$$n = K_{gas}(T)[O_{ads}^{ion}]^a[R]^b \tau + n_0 \quad (20)$$

Where τ is a time constant. At a constant operating temperature the resistivity of a semiconductor is defined as $\rho = \alpha / n$. Where α is a proportionality constant with '+' sign for n-type and '-' sign for p-type semiconductor, and can be substituted in equation (20) as

$$\frac{1}{Rg} = (K_{gas}(T)[O_{ads}^{ion}]^a[R]^b \tau) / \alpha + \frac{1}{Ra} \quad (21)$$

Assuming the concentration of adsorbed test gas ([R]^b) on the sensor surface is linearly proportional to the gas concentration in gas chamber (C_g^b), at constant operating temperature the sensor response relation can be obtained in a compact form

$$R_s = MC_g^b \quad (22)$$

where R_s is response of the sensor and it could be defined as (R_{gas}-R_{air})/R_{air} and M is (K_{gas}(T)[O_{ads}^{ion}]^aτ)R_{air} / α, a constant at constant operating temperature.

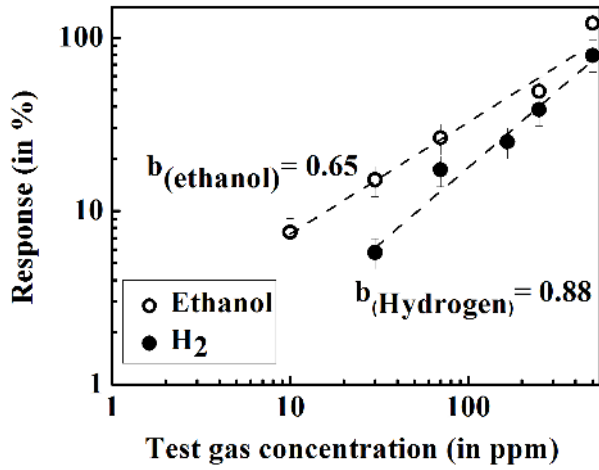


Fig. 6. Response vs. test gas concentration of 25 nm composite thin film at the operating temperature of 400 °C; gas flow rate: 100 cc/min.

TABLE VI
COMPARISON OF OUR EXPERIMENTAL DATA WITH AVAILABLE LITERATURE VALUES OF CuO BASED SENSING MATERIALS

Sensor material	Test gas (ppm)	τ_{res}	τ_{rec}	R_s (%)	O.T. (°C)	Ref.
CuO thin film	H ₂ (10,000)	~10 min	~20 min	40	250	[2]
CuO nanostructures	H ₂ (100)	-	-	50	300	[42]
Porous CuO nanowires	H ₂ (60,000)	~2.5 min	~10 min	400	250	[14]
CuO/ZnO hetero contact	H ₂ (4000)	-	-	25	200	[1]
CuO-CuFe ₂ O ₄ thin film	H ₂ (1250)	190 s	400 s	40	295	[36]
CuO/ZnO hetero contacts	H ₂ (2500)	-	-	79	295	
CuO-CuFe ₂ O ₄ thin film	H ₂ (4000)	-	-	130	400	[15]
CuO nano rods	H ₂ (500)	58 s	221 s	79	400	our work
CuO nano wires	Ethanol (2000)	-	-	160	300	[3]
CuO nano wires	Ethanol (500)	-	-	24	300	[4]
CuO microspheres	Ethanol (1000)	110 s	120 s	50	240	[5]
CuO thin film	Ethanol (200)	-	-	70	240	[6]
CuO thin film	Ethanol (12.5)	-	-	120	180	[7]
CuO-CuFe ₂ O ₄ thin film	Ethanol (500)	90 s	450 s	130	450	our work

Figure 6 shows the variation of response of the 25 nm thin film sensor with gas concentration at the operating temperature of 400 °C. Gas sensing response is following the power law equation (eq. 22) for both the gases in the range of 10 ppm to 500 ppm. Response toward ethanol is slightly higher than that of hydrogen for similar concentration, i.e., this sensor is more sensitive toward ethanol than hydrogen. The obtained value of b is 0.65 for ethanol and 0.88 for hydrogen. This value of b toward ethanol is quite similar with the reported values, 0.677 and 0.54 for ZnO nano rods and nano structured sensing materials respectively [39], [40]. For hydrogen, the value of b was reported as 0.53 for ZnO thin films [41]. The value of b of these sensors was not as close to 0.5. Such deviation might

occur due to the fact that the surface depletion or accumulation layer has some effect on the oxygen adsorption species at metal oxide surface when the grain diameter is close to double of that layer thickness ($2L_d$) [41]. At the operating temperature of 400 °C, both O^- and O^{2-} ion species formation are possible on metal oxide surface [38]; quantitative comparison of these ions at this operating temperature is not available in literature. So, the value of b power law exponent for hydrogen can be in the range of 0.5 to 1 at the operating temperature of 400 °C. The value 0.88 for hydrogen in our case gives an indication of higher concentration of O^- ion than O^{2-} on sensor surface at the operating temperature of 400 °C. Similarly, for ethanol the value can be in the range of 0.08 to 1 at the operating temperature of 400 °C, but the value 0.65 indicates the reduction of ethanol through the formation of acetaldehyde on the sensor surface.

The ethanol and H₂ sensing properties of various CuO nano structures in the literature are summarized in Table VI. Few of them reported higher response in comparison to the current work but at the cost of very high gas concentration [3], [14], [15]. And short response time was observed in this present study among the values reported recently in the literature of CuO sensors.

V. CONCLUSION

The self-organized CuO-CuFe₂O₄ thin films showed p-type semiconductor behaviour with increase in electrical resistance upon exposure to hydrogen or ethanol gas. Good fitting of response or recovery curve with single site gas adsorption model indicates that the reaction had occurred only on the surface of thin films. The developing process of this porous microstructure of top CuO layer is interesting as this kind of sensors have shown improved sensing properties toward reducing gases (e.g. ethanol and hydrogen) compared to the CuO thin film sensors fabricated by other techniques already reported. The best sensing performance was observed for the 25 nm thin film at an operating temperature of 400 °C with a response of 79% toward 500 ppm of H₂ and the response and recovery times obtained at this temperature are ~60 s and ~220 s, respectively. This 25 nm thin film sample also exhibited 128% response toward 500 ppm of ethanol with 90 seconds response time at the operating temperature of 400 °C. Also, we have demonstrated the variation of response of the sensors for a wide range of test-gas concentration. Due to these promising results, we believe that an optimised fabrication of this composite material could be a cheap potential gas sensing candidate only for local target oriented applications where the presence of other interfering gases is in negligible amount (e.g. in breathalyzer, water electrolysis plant). For example, the typical composition of exhaled air is 5.0–6.3% water vapour, 74.4% nitrogen, 13.6–16.0% oxygen, 4.0–5.3% carbon dioxide, <0.1% microbes or volatile organic compounds [43], [44]. Presence of humidity plays a significant role on sensing performance of metal oxide semiconductors at low operating temperatures (<250 °C) by the formation of HO^- at the surface of the semiconductor. Wang *et al.* [45] reported decrease in response of CuO

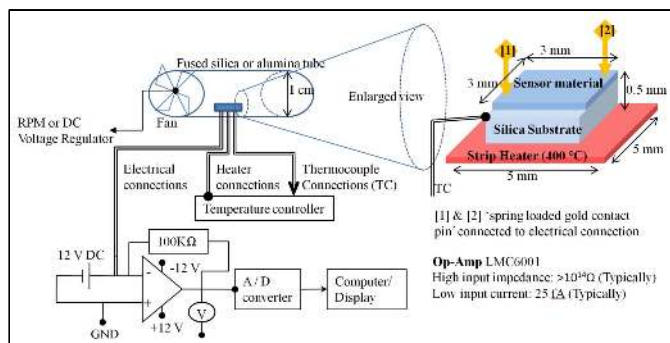


Fig. 7. A schematic illustration of the proposed sensing device using CuO-CuFe₂O₄ composite thin film.

sensor toward reducing gas (e.g. ethanol) with increase in relative humidity at the operating temperature of 220 °C. Morimoto *et al.* [46] showed that the most of the water content desorbed from metal oxides (e.g TiO₂, ZnO, α -Fe₂O₃) surface at the operating temperature of 400 °C. So, the effect of moisture on this sensor performance can be negligible as it will be operated at 450 °C. In our earlier studies, it was observed that the response of the same sample toward CO₂ was very slow with response time of \sim 9.5 hour and maximum response of \sim 50% was observed at 250 °C which reduced below 10% at higher operating temperature (400 °C) [47]. So, fabrication of a practical breath-alcohol tester can be possible for its fast response time (1.5 min) and recovery time (7.5 min) with high response toward ethanol at 450 °C. Similarly, it can be used as cheap alarm for hydrogen-leakage, e.g., at water electrolysis plant (where the presence of alcohol or volatile organic compound is negligible or rare). A schematic illustration of the proposed sensing device is given in the figure 7. This proposed sensor should be operated at normal air atmosphere (\sim 20% O₂), where oxygen will not vary to that much extent in this environment. Though, in our future work, we plan to investigate the effect of oxygen concentration at ambient atmosphere on the sensing performance of this CuO–CuFe₂O₄ composite sensing material.

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